

L Number	Hits	Search Text	DB	Time stamp
1	2	("6190459") or ("6246030").PN.	USPAT	2004/07/22 13:41
-	1500	(219/390 or 219/405 or 219/411 or 392/416 or 392/418 or 118/724 or 118/725 or 118/50.1).ccIs. and ((substrate\$1 or wafer\$1) and gases\$2)	USPAT	2004/07/20 15:36
-	885	((219/390 or 219/405 or 219/411 or 392/416 or 392/418 or 118/724 or 118/725 or 118/50.1).ccIs. and ((substrate\$1 or wafer\$1) and gases\$2)) and (gas\$2 near10 ((top or above or over or high) and (bottom or below or under or low\$2)))	USPAT	2004/07/20 15:27
-	74	(((219/390 or 219/405 or 219/411 or 392/416 or 392/418 or 118/724 or 118/725 or 118/50.1).ccIs. and ((substrate\$1 or wafer\$1) and gases\$2)) and (gas\$2 near10 ((top or above or over or high) and (bottom or below or under or low\$2)))) and ((float\$3 or levitat\$3) near10 (substrate\$1 or wafer\$1))	USPAT	2004/07/20 13:31
-	885	((219/390 or 219/405 or 219/411 or 392/416 or 392/418 or 118/724 or 118/725 or 118/50.1).ccIs. and ((substrate\$1 or wafer\$1) and gases\$2)) and (gas\$2 near10 ((top or above or over or high) and (bottom or below or under or low\$2)))	USPAT	2004/07/20 15:29
-	101	(((219/390 or 219/405 or 219/411 or 392/416 or 392/418 or 118/724 or 118/725 or 118/50.1).ccIs. and ((substrate\$1 or wafer\$1) and gases\$2)) and (gas\$2 near10 ((top or above or over or high) and (bottom or below or under or low\$2))) ) and ((move\$1 or moving or movable or moveable or adjust\$4) near10 (top or lid or cover))	USPAT	2004/07/22 12:02
-	1500	(219/390 or 219/405 or 219/411 or 392/416 or 392/418 or 118/724 or 118/725 or 118/50.1).ccIs. and ((substrate\$1 or wafer\$1) and gases\$2)	USPAT	2004/07/20 15:36
-	101	(((219/390 or 219/405 or 219/411 or 392/416 or 392/418 or 118/724 or 118/725 or 118/50.1).ccIs. and ((substrate\$1 or wafer\$1) and gases\$2)) and (gas\$2 near10 ((top or above or over or high) and (bottom or below or under or low\$2))) ) and ((move\$1 or moving or movable or moveable or adjust\$4) near10 (top or lid or cover))) and ((move\$1 or moving or movable or moveable or adjust\$4) near10 (top or lid or cover))	USPAT	2004/07/22 11:54

	0	((((219/390 or 219/405 or 219/411 or 392/416 or 392/418 or 118/724 or 118/725 or 118/50.1).ccls. and ((substrate\$1 or wafer\$1) and gases\$2)) and (gas\$2 near10 ((top or above or over or high) and (bottom or below or under or low\$2))) ) and ((move\$1 or moving or movable or moveable or adjust\$4) near10 (top or lid or cover))) and ((move\$1 or moving or movable or moveable or adjust\$4) near10 (top or lid or cover))) not ((219/390 or 219/405 or 219/411 or 392/416 or 392/418 or 118/724 or 118/725 or 118/50.1).ccls. and ((substrate\$1 or wafer\$1) and gases\$2) )	USPAT	2004/07/20 15:37
-	484	(mita).inv.	USPAT	2004/07/22 11:55
-	95	((mita).inv.) and (substrate\$1 or wafer\$1)	USPAT	2004/07/22 11:58
-	25	("3854443") or ("3947236") or ("4495024") or ("4560590") or ("4574093") or ("4575408") or ("4662918") or ("4662987") or ("4903717") or ("4903754") or ("4958061") or ("5318801") or ("5356476") or ("5431700") or ("5447431") or ("5520538") or ("5542559") or ("5772770") or ("5778968") or ("5881208") or ("5927077") or ("5937541") or ("5960159") or ("6099056") or ("6183565")).PN.	USPAT	2004/07/22 11:58
-	311	(219/390 or 219/405 or 219/411 or 392/416 or 392/418 or 118/724 or 118/725 or 118/50.1).ccls. and ((move\$1 or moving or movable or moveable or adjust\$4) near10 (top or lid or cover))	USPAT	2004/07/22 12:02
-	101	((219/390 or 219/405 or 219/411 or 392/416 or 392/418 or 118/724 or 118/725 or 118/50.1).ccls. and ((substrate\$1 or wafer\$1) and gases\$2)) and (gas\$2 near10 ((top or above or over or high) and (bottom or below or under or low\$2))) ) and ((move\$1 or moving or movable or moveable or adjust\$4) near10 (top or lid or cover))	USPAT	2004/07/22 12:03
-	210	((219/390 or 219/405 or 219/411 or 392/416 or 392/418 or 118/724 or 118/725 or 118/50.1).ccls. and ((move\$1 or moving or movable or moveable or adjust\$4) near10 (top or lid or cover))) not (((219/390 or 219/405 or 219/411 or 392/416 or 392/418 or 118/724 or 118/725 or 118/50.1).ccls. and ((substrate\$1 or wafer\$1) and gases\$2)) and (gas\$2 near10 ((top or above or over or high) and (bottom or below or under or low\$2))) ) and ((move\$1 or moving or movable or moveable or adjust\$4) near10 (top or lid or cover)) )	USPAT	2004/07/22 13:41